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PATENT

2176

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

INFORMATION
DISCLOSURE
STATEMENTRECEIVED
JAN 14 2003
Technology Center 2600

Inventors: Andrew Rodney Ferlitsch

Serial No: 09/683,667

Filed: January 31, 2002

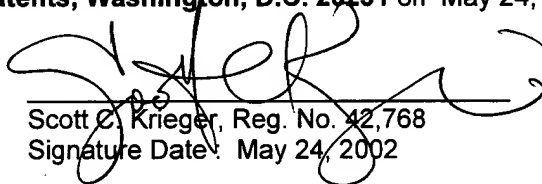
Title: METHODS AND SYSTEMS FOR
PRINT SYSTEM COMPONENT-
BASED REMOTE PRINTINGAttorney Docket No.
SLA1038**RECEIVED**

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CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited
in the United States Postal Service with sufficient postage as first
class mail in an envelope addressed to: **Commissioner
for Patents, Washington, D.C. 20231** on May 24, 2002



Scott C. Krieger, Reg. No. 42,768
Signature Date: May 24, 2002Commissioner for Patents
Washington, D.C. 20231**INFORMATION DISCLOSURE
STATEMENT UNDER 37 C.F.R. §1.97(b)**

Sir:

Applicants herewith submit information in the above-identified application
for consideration by the Examiner. A first Office Action on the merits not having
been received, applicants submit this information under 37 C.F.R. §1.97(b)(3).

PATENT

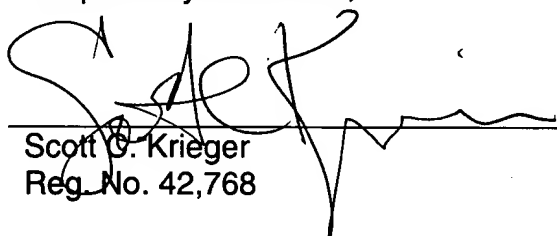
The information is listed on attached Form PTO-1449 and is submitted pursuant to 37 C.F.R. §1.56. A copy of each listed publication is submitted. The foreign patent documents listed herewith are accompanied by the English-language translations of the abstracts as provided by the Japanese Patent Office. These English-language abstracts may be referred to for a statement of relevance of the associated documents. The inventors, attorney, and any others substantially involved in the preparation or prosecution of this U.S. application are only aware of information in the English-language abstracts and graphical information in the figures of the references.

Applicants respectfully request that the listed information be considered by the Examiner and made of record in the above-identified application.

The Commissioner is hereby authorized to charge any additional fees associated with this communication, or credit any overpayment, to Deposit Account No. 50-0803. A duplicate copy of this authorization is enclosed.

May 24, 2002

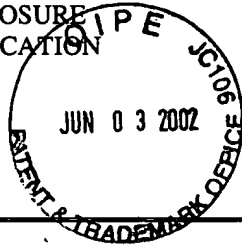
Respectfully submitted,



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FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION	DOCKET NUMBER SLA1038	APPLICATION NUMBER 09/683,667
	APPLICANT Andrew Rodney Ferlitsch	
	FILING DATE: January 31, 2002	GROUP ART UNIT 2176



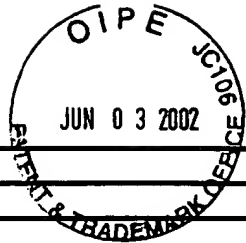
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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILE. DATE IF APPROP.
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EXAMINER	DATE CONSIDERED
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